

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kuthi, et al.

Application No: 09/611,037

Filed: July 6, 2000

For: METHOD FOR MAKING A
SEMICONDUCTOR PROCESS
CHAMBER ELECTRODE



Docket No: LAM1P077A

Group Art Unit: 1763

Examiner: Alejandro, L.

Date: May 28, 2002

#6C
#1
6/13/02
nm

CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington DC 20231 on May 28, 2002.

Signed: _____

Neely V. Weldy

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

RECEIVED
JUN 11 2002
TC 1700
COPY OF PAPERS
ORIGINALLY FILED

Dear Sir:

Applicants submit this paper in response to the Office Action dated February 27, 2002. The period for response extends to May 28 2002. Please enter the following amendments and remarks:

IN THE DRAWINGS

Proposed amended Figures 1E and 2A are herein submitted with amendments shown in red. In Figure 1E, a first instance of the call-out "140" has been changed to "141." In Figure 2A, the call-out "256" is legibly inserted into the location from which it was partially cut off in the originally submitted informal drawing.